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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tews, et al. Docket No.: 2004 P 51343 US  
 Serial No: 10/840,146 Art Unit: 2812  
 Date Filed: May 6, 2004  
 Title: Semiconductor Structures and Manufacturing Methods

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Respectfully submitted,

*Natalie Swider*  
 Natalie Swider  
 Legal Assistant

**Confirmation Respectfully Requested**

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